

Amendments to the Claims

This listing of claims will replace all prior versions, and listings of claims in the application.

Listing of Claims:

1. (currently amended) A wiring structure comprising:
an insulating layer including a grove groove;
a plurality of slit dummies each of which is spaced from each other in
the grove groove; and
a wiring which is formed in the grove groove, the wiring has a first
portion which has having a thickness H (nm) and a width W (μm) that is larger
longer than a reference width Wmax (μm), wherein the maximum width Wmax
is calculated from the following equation, Wmax = Exp (H/735), and has a
second portion which has a width narrower than the reference width;
wherein a distance L between the slit dummies are is less than the
maximum width Wmax, a width of the reference width;
— wherein the slit dummies are not formed in the second portion of the
wiring.
2. (cancelled)
3. (currently amended) A wiring structure according to claim 2 1,
wherein the slit dummies are arranged in a line and arranged along a direction
in which the wiring extends.
4. (original) A wiring structure according to claim 3, wherein the slit
dummies are arranged spaced equally.

5. (currently amended) A wiring structure according to claim 1 2, wherein the slit dummies are arranged in plural a plurality of lines, and wherein the slit dummies in the plurality of lines are arranged in staggered form.

6. (original) A wiring structure according to claim 5, wherein the slit dummies are arranged spaced equally.

7. (original) A wiring structure according to claim 6, wherein the slit dummies arranged in one of the lines are arranged adjacent to the edge of the wiring.

8. (currently amended) A wiring structure according to claim 1 6, wherein a distance between the lines slit dummies is approximately $\frac{\sqrt{3}}{2}$ $\sqrt{3}$ half of reference the maximum width Wmax.

9. (currently amended) A wiring structure according to claim 1 2, wherein a distance between slit dummies is are approximately 85% of the maximum width Wmax, of the reference width.

10. (currently amended) A wiring structure according to claim 1, wherein a material of the slit dummies are is the same as that of the insulating layer.

11. (new) A conductive pattern structure comprising:
a semiconductor substrate;
an insulating layer formed on the semiconductor substrate, the insulating layer having a groove;
a conductive pattern formed in the groove of the insulating layer, the conductive pattern having a thickness H (nm) and a width W (μ m) that is larger than a maximum width Wmax (μ m), wherein the maximum width Wmax is calculated from the equation,

$$W_{max} = \text{Exp} (H/735); \text{ and}$$

a plurality of split dummies formed in entire thickness of the conductive pattern, the slit dummies being formed of an insulating material and being separated by a distance L that is less than the maximum width Wmax.

12. (new) A conductive pattern structure according to claim 11, wherein the slit dummies are arranged in a line and arranged along a direction in which the conductive pattern extends.

13. (new) A conductive pattern structure according to claim 11, wherein the slit dummies are arranged apart at equally spaced distances.

14. (new) A conductive pattern structure according to claim 11, wherein the distance between the slit dummies is approximately $\frac{\sqrt{3}}{2}$ of the maximum width Wmax.

15. (new) A conductive pattern structure according to claim 11, wherein the slit dummies are arranged in a plurality of lines, and wherein the slit dummies in the plurality of lines are arranged in staggered form.

16. (new) A conductive pattern structure according to claim 15, wherein the lines are arranged with a pitch S that is larger than the distance L.

17. (new) A conductive pattern structure according to claim 11, wherein each of the slit dummies has a substantial square form.

18. (new) A conductive pattern structure according to claim 11, wherein a material forming the insulating layer is the same as material forming the slit dummies.